

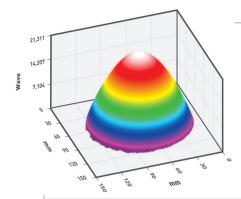


Interferometric solution for filters and coated optics testing at dedicated wavelengths

PHASICS is innovating in optical metrology with a new instrument able to measure both transmitted and reflected wavefront error (TWE/ RWE). Coated and uncoated optics can be qualified over a diameter of 5.1 inches (130 mm) at their working wavelengths.

Kaleo MultiWAVE is an advantageous alternative and costeffective solution to the purchase of several interferometers. The system offers a **measurement accuracy comparable to Fizeau interferometry.**

Kaleo MultiWAVE works at different wavelengths to perform qualification of optics and coatings at their working wavelengths.



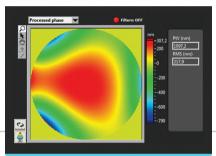
HIGH DYNAMIC RANGE

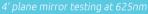
MEASUREMENT OF LARGE ABERRATIONS

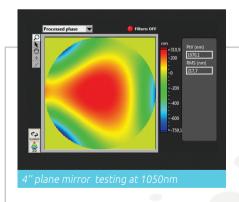
- More than 20λ of aberration can be measured with Kaleo MultiWAVE
- More dynamic range than a classical Fizeau interferometer

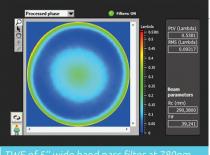
APPLICATIONS

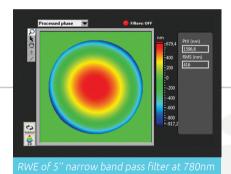
- Coated optics and filters testing at real operating wavelengths
- High dynamics surface testing











ACHROMATIC SYSTEM

Same results at any wavelength

The instrument can be used at any wavelength to match the sample's operating wavelength

KEY FEATURES







High dynamic range



WFE & MTF measurement



Insensitive to vibration



Compatible with MetroPro & ISO

SYSTEM			
Configuration	Double pass		
Measurement capability	RWE of reflective surfaces TWE of transparent optics		
Number of wavelengths per instrument	1 or 2 (standard), up to 8 (custom)		
Custom wavelengths	Any wavelength from 193 nm to 14µm inculding: UV: 266, 355, 405 nm VIS/NIR: 550, 625, 780, 940, 1050 nm SWIR/MWR/LWIR: 1.55, 2.0, 3.39, 10.6 µm		
Clear aperture	5.1" (130 mm)		
Beam height	108 mm		
Alignment system	Live phase & Zernike cofficients display		
Polarization	Compatible with depolarizing optics		
Alignment FOV	+/- 2°		
Pupil focus range	+/- 2.5 m		
Dimension/Weight	910x600x260 mm³ , 25 kg		
Vibration isolation	Not necessary		

PERFORMANCES(1)			
RMS repeatability (2)	<0.7 nm (< λ /900)		
Accuracy	80 nm PV (3)		
Dynamic range (defocus)	500 fringes (SFE=150 μm)		
Sample reflectivity range	~4% - 100%		

⁽¹⁾ On a 4" pupil size, with a 625 nm source

MARKETS







Space & Defense



Automotive

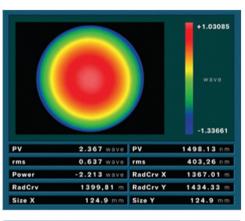
^{(2) 36} sequential measurements are performed on a 4" reference mirror, each being averaged 16 times. A reference is defined as the average of all odd numbered measurements. RMS repeatability is then defined as the average RMS difference plus 2 times the standard deviation of the difference between even numbered measurements and the reference.

⁽³⁾ For a 1 μ m PV defocus.

RESULTS SIMILAR TO FIZEAU INTERFEROMETRY

FIZEAU INTERFEROMETER

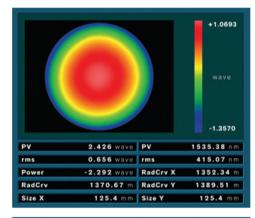
KALEO MULTIWAVE

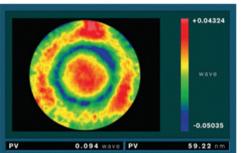


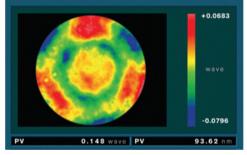
RAW MEASUREMENT

(raw power, ast, coma, spherical)

RESIDUAL

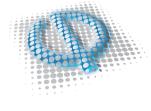






NBP-780nm - The difference between the 2 measurements on the same pupil is below 40

		FIZEAU	PHASICS
Diameter (mm)		124.9	125.4
RWE (nm PtV)		1498.13	1535.38
RWE (nm RMS) without PST/TLT/PWR		35.2	28.1
RWE (nm RMS) without ST/TLT/PWR/AST/CMA/SA		9.1	12.9
ISO 10110	SAG (fr)	5.13	5.04
	IRR (fr)	0.75	0.61
	RSI (fr)	0.34	0.23
	RMSt (fr)	1.477	1.459
	RMSi (fr)	0.129	0.103
	RMSa (fr)	0.085	0.059



PHASICS

the phase control company

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